

PATENT ASSIGNMENT

Electronic Version v1.1
Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE
CONVEYING PARTY DATA	
Name	Execution Date
Georgia Tech Research Corporation	04/19/2010
RECEIVING PARTY DATA	
Name:	National Science Foundation
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Internal Address:	Room 1265
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State/Country:	VIRGINIA
Postal Code:	22230
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	12514358
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PATENT
REEL: 026639 FRAME: 0522

License to the United States Government

Invention Title: Printable Thin-Film Transistors with High Dielectric constant Gate Insulators and Methods for Producing Same

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U.S. Filing/Issue Date: 10/7/2009

Patent or Application Serial No.: 12/514,358

Grant/Contract Number(s): N00014-05-1-0760, DMR-0120967

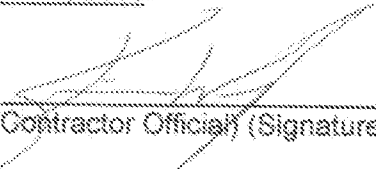
Foreign Applications filed/intended in (countries):

The invention identified above is a Subject Invention under 35 U.S.C. 200, et seq., and the Standard Patent Rights clause at 37 CFR 401.14, FAR 52.227-11 or FAR 52.227-12 (if applicable) which are included among the terms of the above identified grant or contract award from the United State Government. This document is confirmatory of:

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The Government is hereby granted an irrevocable power to inspect and make copies of the above-identified patent application.

Signed this day April 19, 2010.

By Kevin Wozniak 
(Name of Grantee/Contractor Official) (Signature)

Title Director, Office of Technology Licensing

For: GEORGIA TECH RESEARCH CORPORATION
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